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Docket No.: FUT-0104
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Masaaki Nagatsu

Application No.: 10/593,325

Confirmation No.: 8431

Filed: September 18, 2006

Art Unit: 1744

For: Microwave Plasma Sterilizing Method and
Device

Examiner: Darrell C Cottman

STATUS INQUIRY

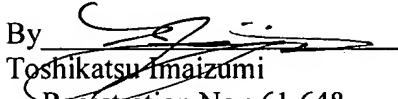
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

It is respectfully requested that the attorney named below be advised of the status of the above-identified application. Please advise us of when we might expect to receive an Office Action from the Patent and Trademark Office.

Dated: September 18, 2008

Respectfully submitted,

By 
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